


# **STRAW Gauge: from UHV to XHV in One Package... R&D through Beta Testing**

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## **Funding**

Department of Energy SBIR Grant DE-SC0004437



**U.S. DEPARTMENT OF ENERGY**

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SBIR: Small Business Innovation Research → Phase I = 9 months: proof of principle  
Phase II = 2 years: completion of project

# Outline

- Motivation
  - Nuclear physics  $e^-$  sources
  - Improved vacuum monitor
  
- Instrument components
  - Hardware
  - Software
  
- Instrument operation
  - In use
  - Calibration and data
  
- Sensor
  - Construction and operation
  - Details, details, details...
  
- Add-ons/spin-outs
  - Software
  - Hardware
  
- Summary



STRAW Vacuum Gauge

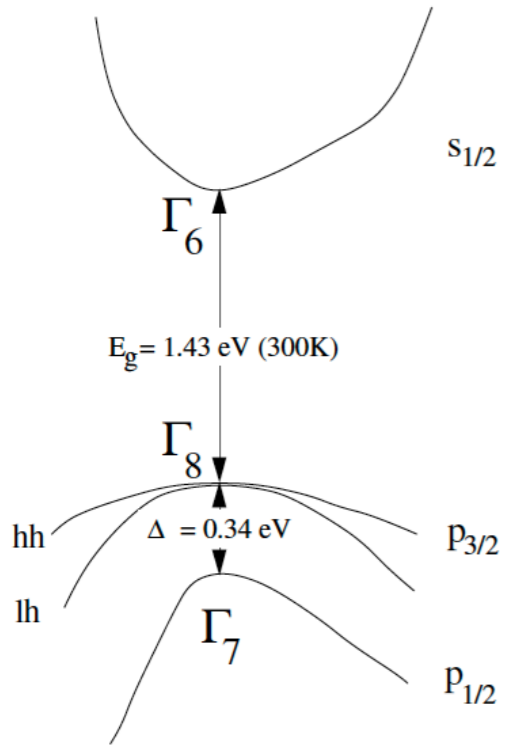
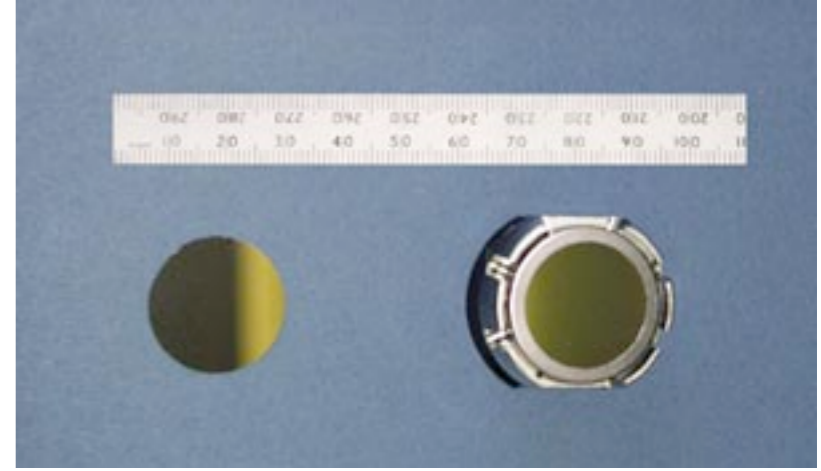
• Motivation: Monitor environment in nonperturbing manner

– Photocathode

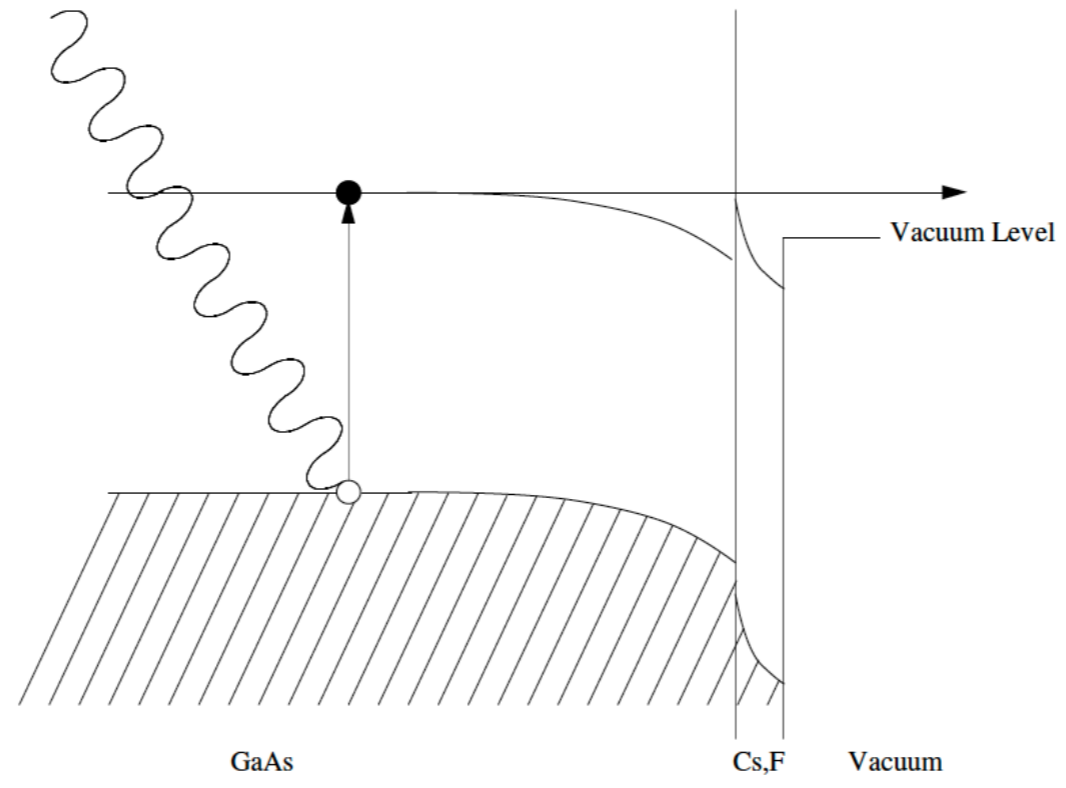
- \* Source of free electrons
- \* Electrons ejected upon photon absorption
- \* Anything with sufficiently high  $h\nu$

– Semiconductor (NEA GaAs)

- \* Activation allows bandgap energy excitation to generate free electrons
- \* Very sensitive to background gas contamination (shortened lifetime)
- \* Manipulation of crystalline symmetry enables high electron spin-polarization



GaAs band structure in vicinity of  $\Gamma$  point



NEA Surface

Gas + charged particles = damage!

Kinetic Damage

Chemical Changes



Gas + charged particles = damage!



Kinetic Damage

Chemical Changes

Gas + charged particles = damage!



Kinetic Damage



Chemical Changes

# How to monitor extremely low pressures (UHV-XHV)?

- Pressure ranges of interest: lower pressure = longer photocathode lifetimes

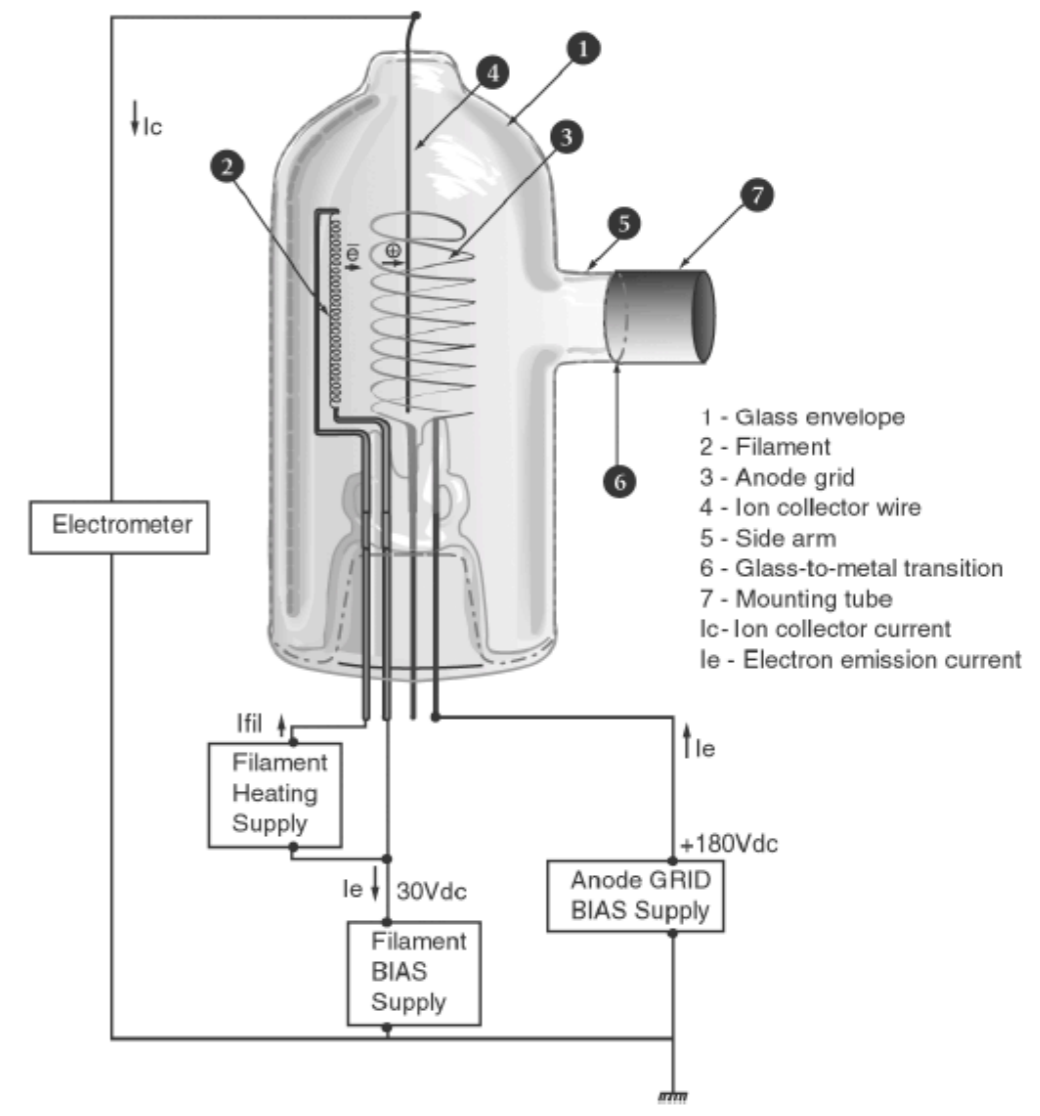
- UHV (Ultra-high vacuum)
  - $1 \times 10^{-12} \text{ Torr} < P < 1 \times 10^{-9} \text{ Torr}$
- XHV (Extreme-high vacuum)
  - $P < 1 \times 10^{-12} \text{ Torr}$

- Ion gauge: particle and heat generation

- Standard (Bayard-Alpert,  $1 \times 10^{-11}$  Torr, x-ray limit)
- Extractor (Redhead 1960s, extends to  $1 \times 10^{-12}$ , Leybold, Ulvac)
- Radioisotope powered (no heater)

- Cold cathode gauge: particle generation

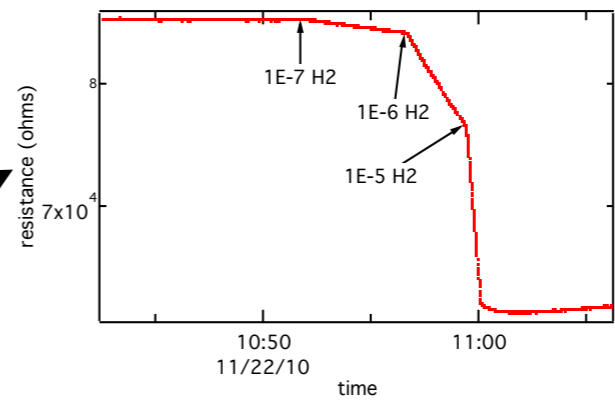
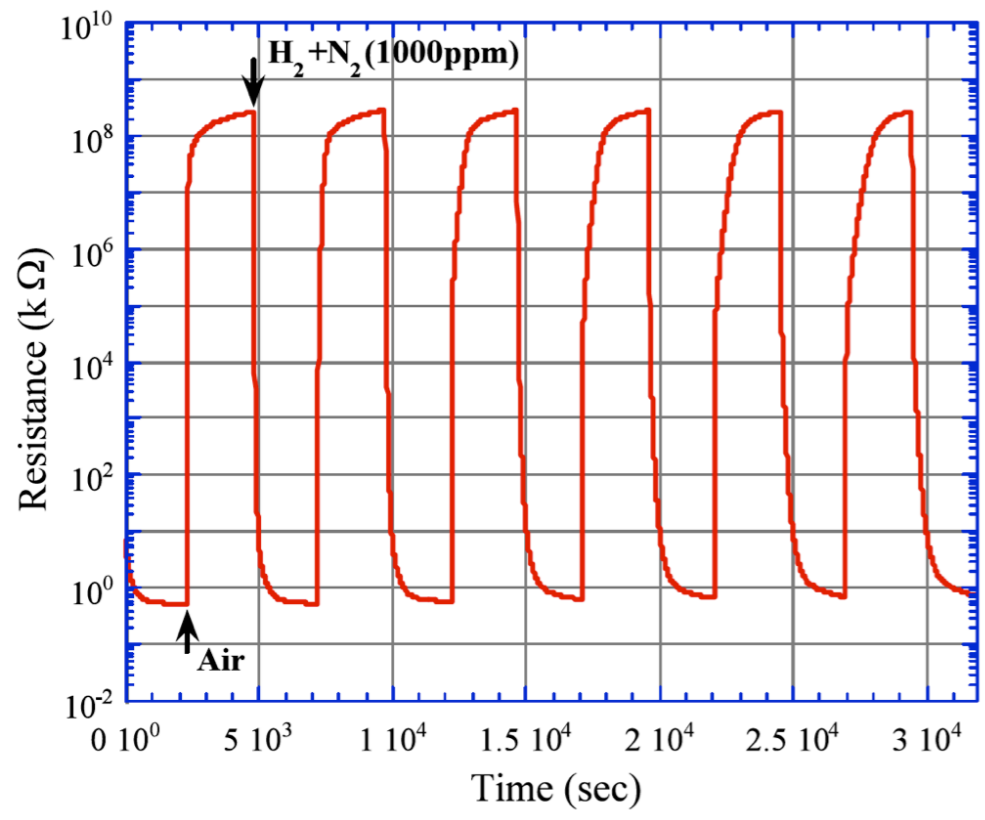
- Commercial UHV (Balzers,  $7.5 \times 10^{-12}$  Torr)
- Ion pump (Very low current monitoring: leakage currents, pump 'sleep')



SRS Ion gauge diagram (IGC100 manual)

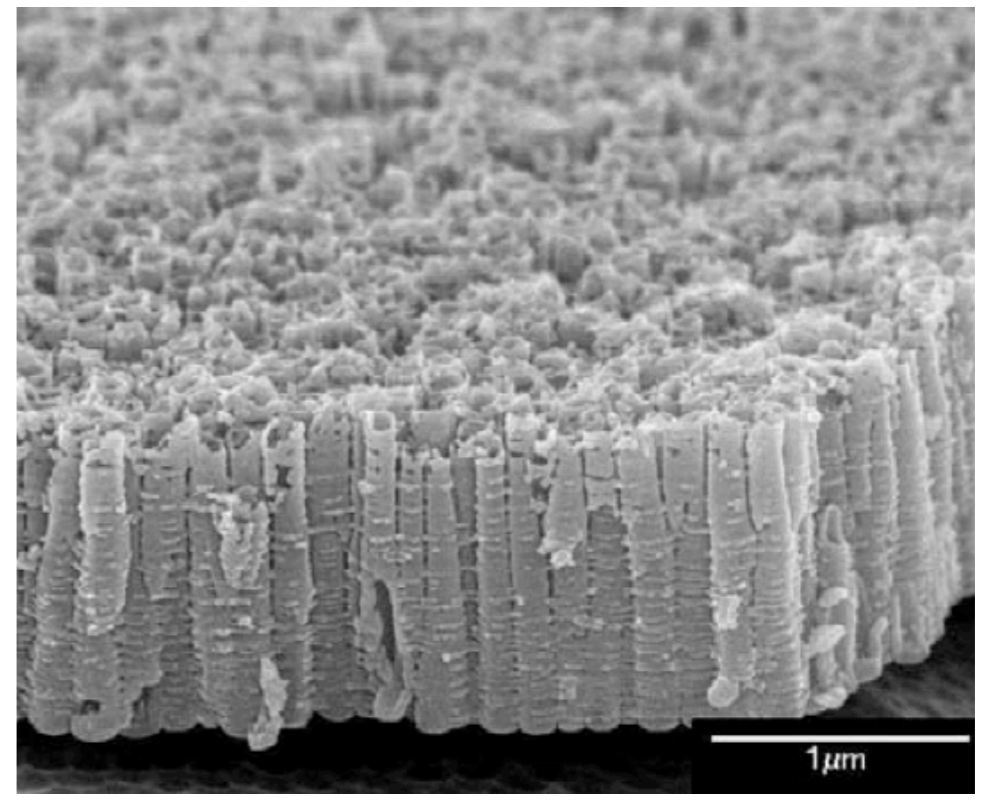
# UHV/XHV gas primarily hydrogen

- Titania (titanium oxide) nanotube arrays have very strong response to hydrogen at STP
- Phase I result: even stronger than anticipated in vacuum



Vacuum hydrogen response of titania nanotubes. Rate is proportional to pressure.

Time response of resistance for hydrogen purged (dry air) and hydrogen dosed (H<sub>2</sub> + N<sub>2</sub>) using 1000 ppm of hydrogen [figure 3 of M. Paulose, O.K. Varghese, G.K. Mor, C.A. Grimes and K.G. Ong, Unprecedented Ultra-High Hydrogen Gas Sensitivity in Undoped Titania Nanotubes, *Nanotechnology* **17**, 398(2006)]



SEM cross section of titania nanotubes



- Instrument components




- Components

- \* Sensor head
- \* Custom designed control unit
- \* Software for DAQ



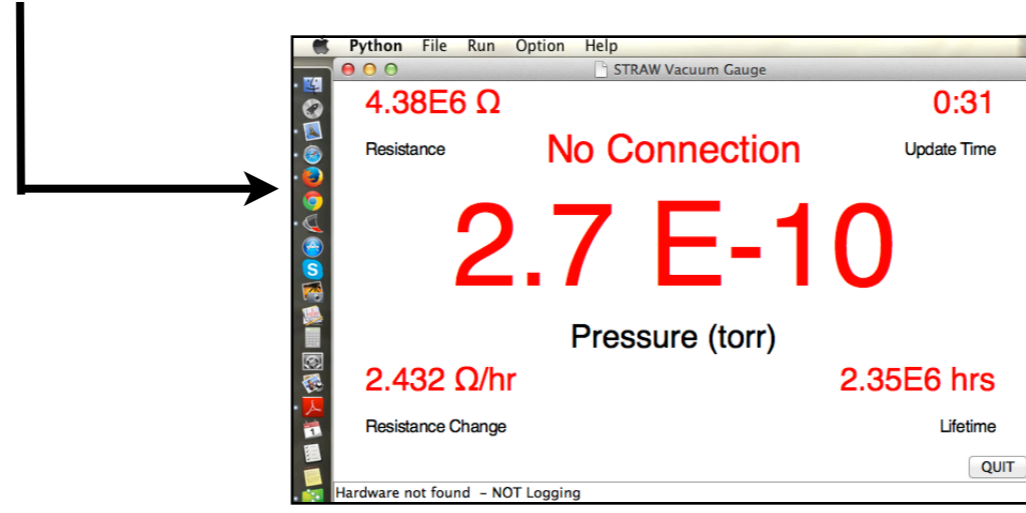
Similar form factor to modern RGA systems, e.g. MKS Microvision.

– Hardware

- \* Sensor head
  - Vacuum feedthrough with electrical and optical transport
  - Device bias/measure, thermocouple and illumination
- \* Control box 
  - Custom designed circuit board: source/measure using 32 bit PIC running @ 20 MHz
- \* Power supplies/cabling
  - Separate power conversion box (AC to DC) to minimize noise

– Software

- \* Onboard controller firmware (programmed in C)
- \* Python for computer interface (NumPy + SciPy)
- \* Packaged installer (Windows via Py2exe)
- \* Manual install for Mac or Linux

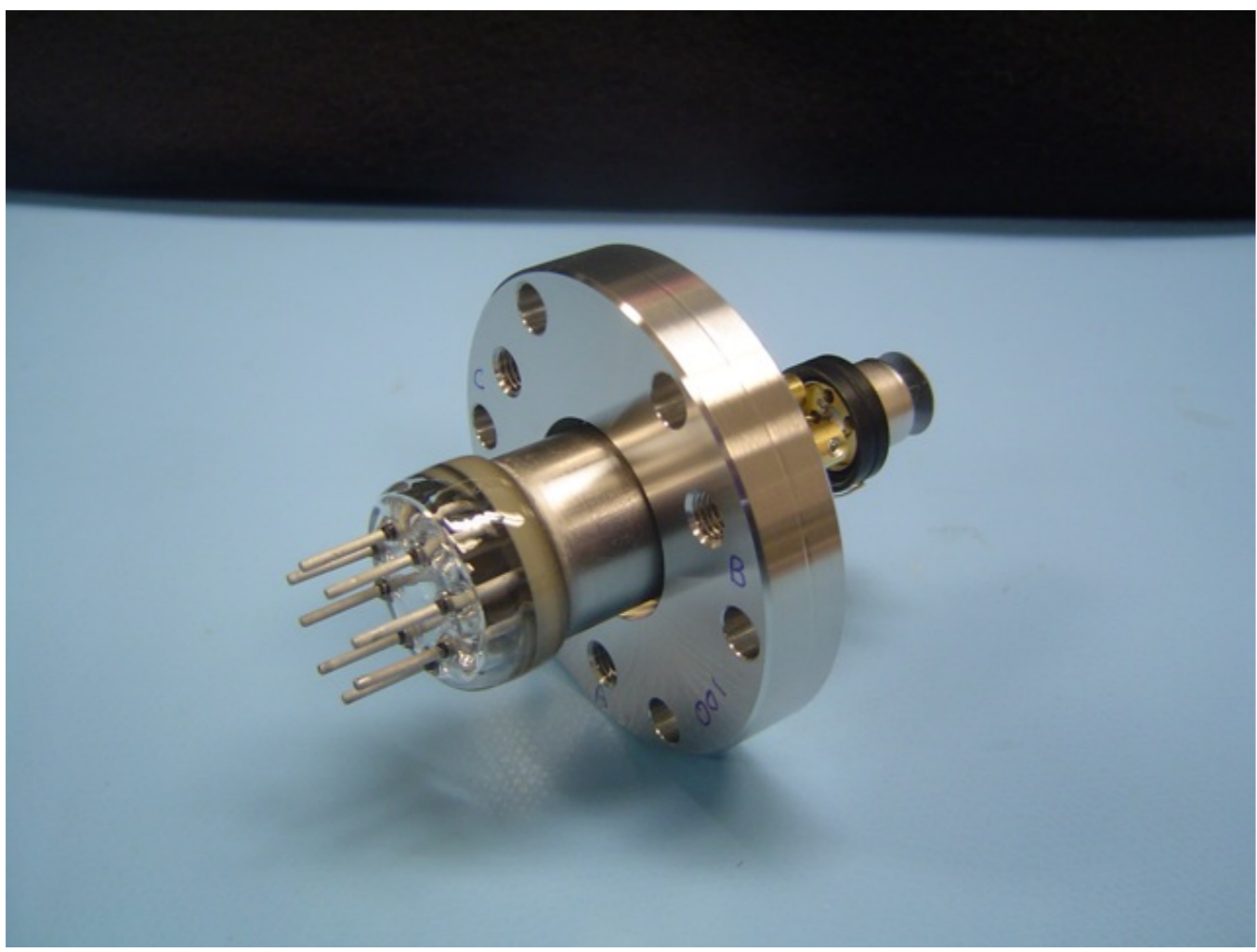


STRAW Control Box Disassembled (optic plate not shown)



\* Sensor head flange

- SST 304L 2-3/4" Conflat type: Larson Electronic Glass Products
- Glass feedthrough functions as optical window to back of nanotube array
- Pin configuration is that of the old Loctal vacuum electron tube
- Air side threaded holes for control box support rods



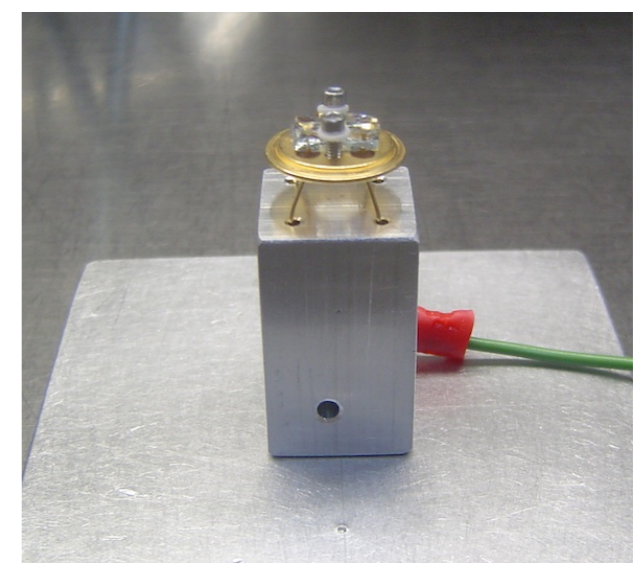
STRAW gauge sensor head flange  
Air side is to left, vacuum to right



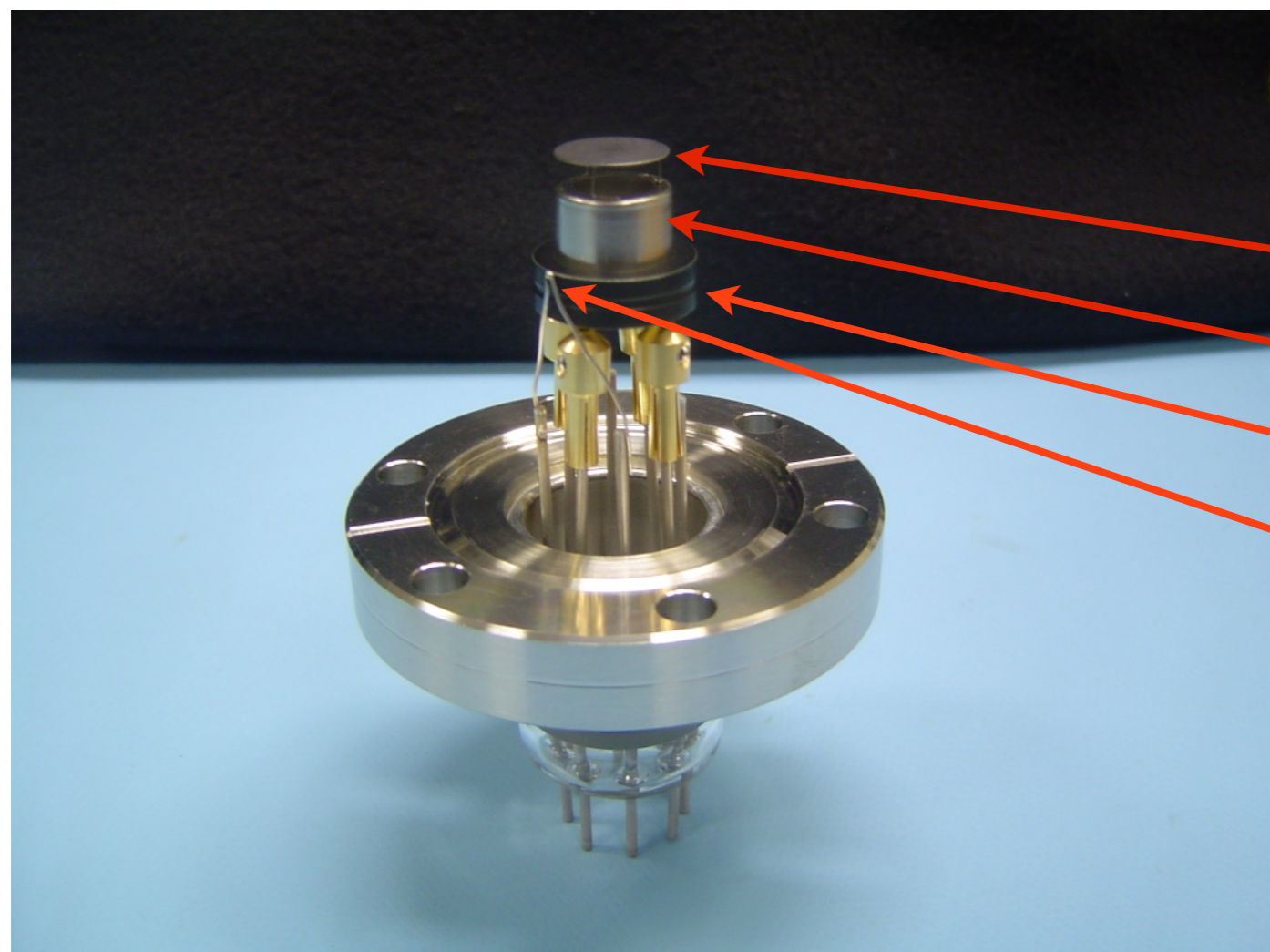
Loctal socket (front)

\* Sensor head flange connections

- Titania nanotube array sensor is mounted on TO8-550 header
- Sensor is mounted inside of physical shield with top hat light baffle
- Near-device temperature is monitored by type K thermocouple
- All four legs of the header are wired to the air side; only one pair used at a time



Leg alignment jig



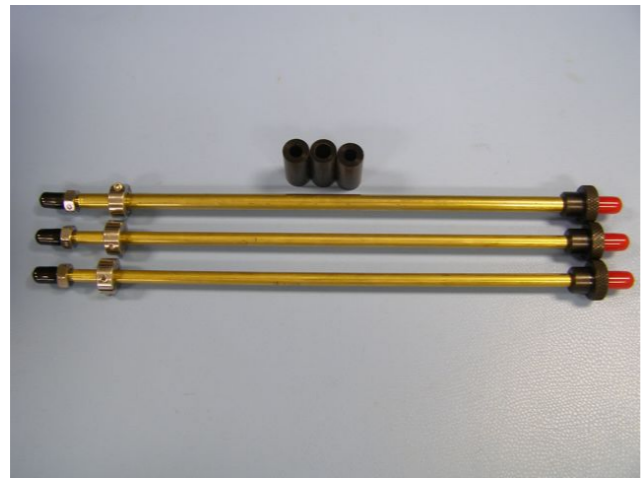
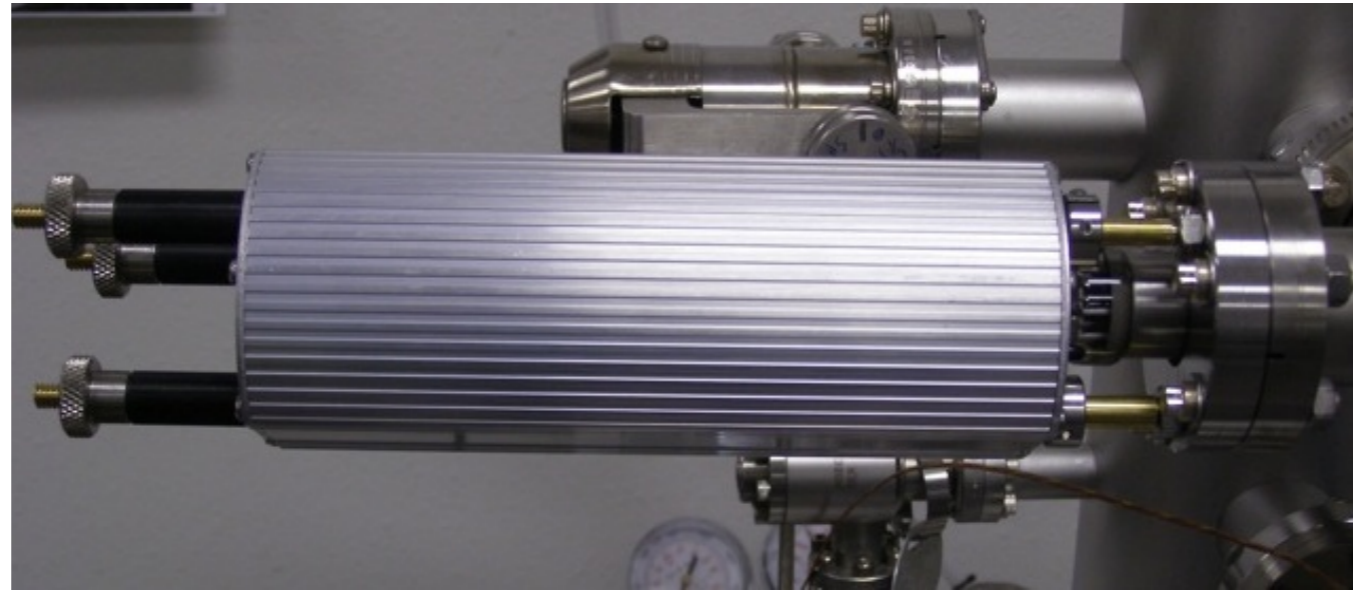
- Light baffle
- Physical shield
- Shield clamp
- Thermocouple

STRAW gauge sensor head flange  
Sensor is mounted inside of shield

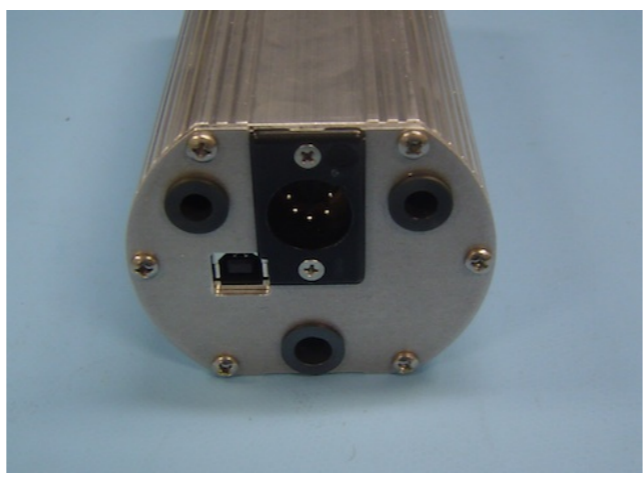


\* Control box

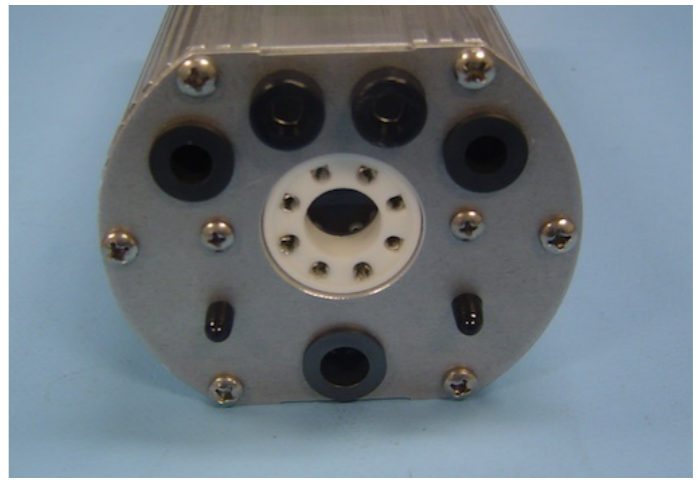
- Externally powered, flange mounted chassis
- PIC controlled, USB-to-serial communicating measurement board (COM emulation)
- Onboard thermocouple readout
- Optical boost LED output with photodiode monitor



Support rod assembly



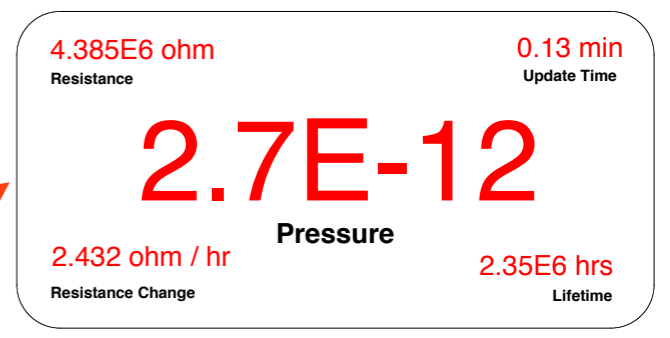
Rear of control box



Front of control box

\* Software

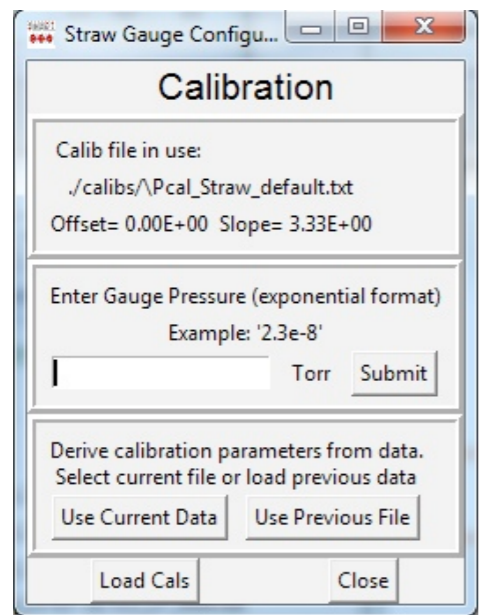
- PIC firmware developed in C
- Host computer control program developed in Python
- Data logging as standard
- Cross calibration data input by end user
- Conductance replaces resistance (X vs. 1/X)



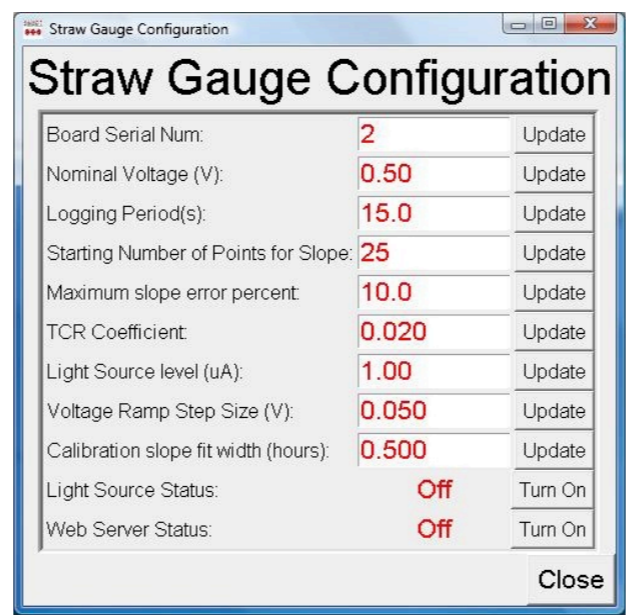
Mockup of main display window from Phase II proposal



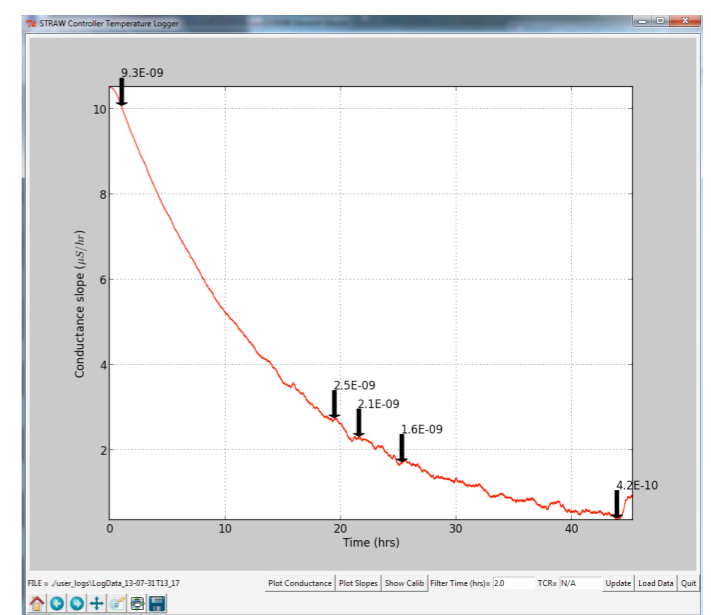
Main Display



Calibration panel



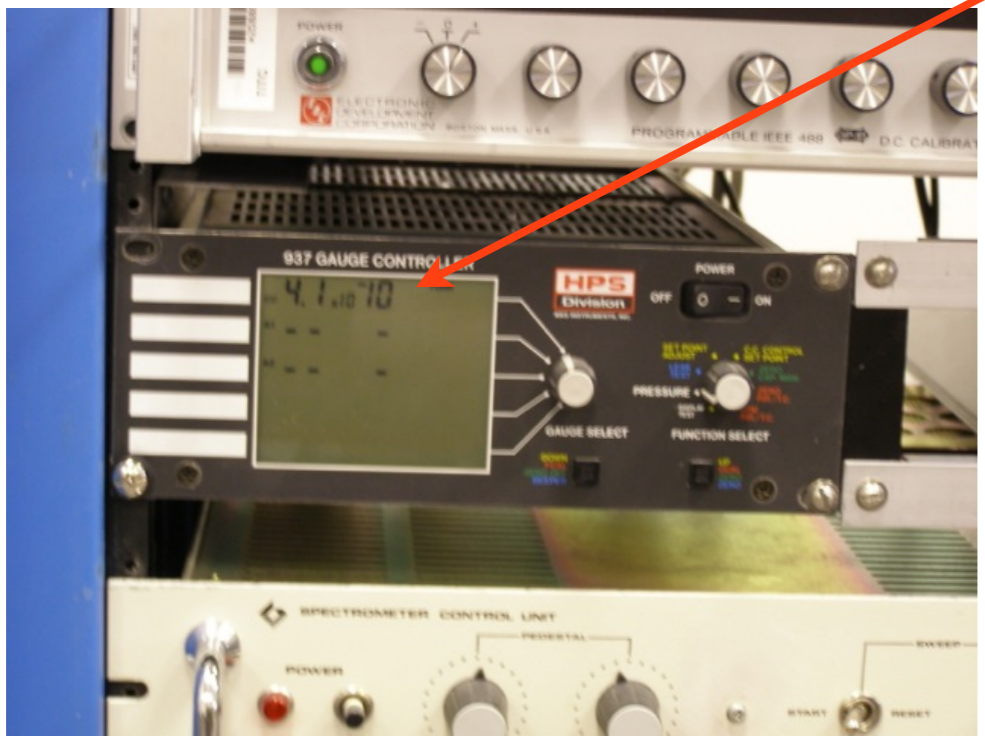
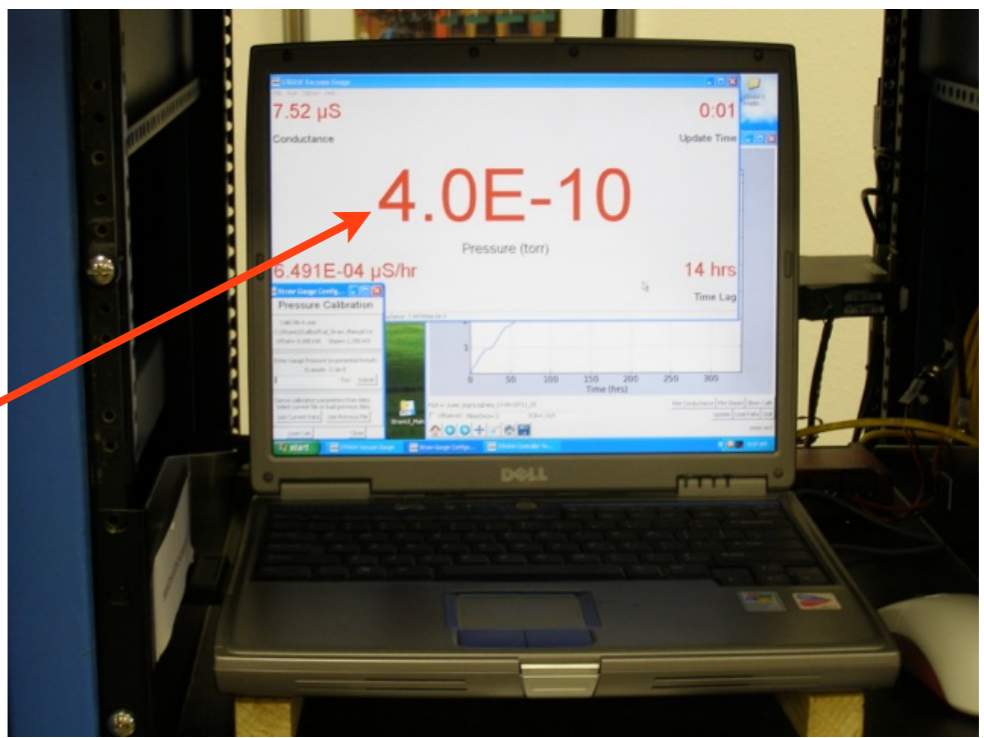
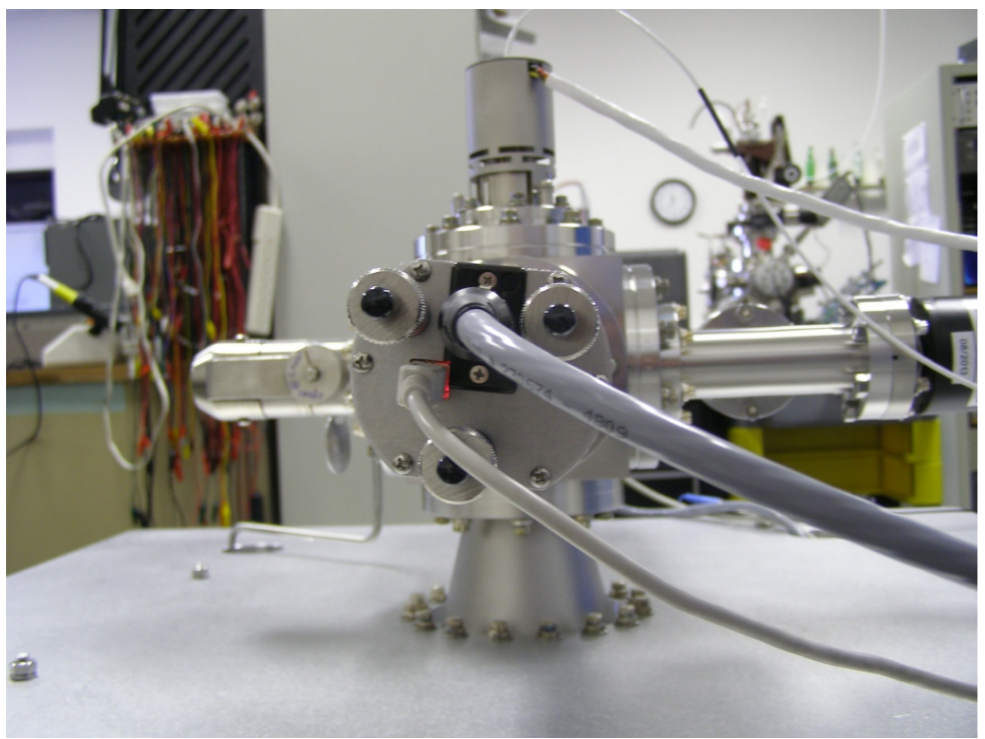
Configuration panel



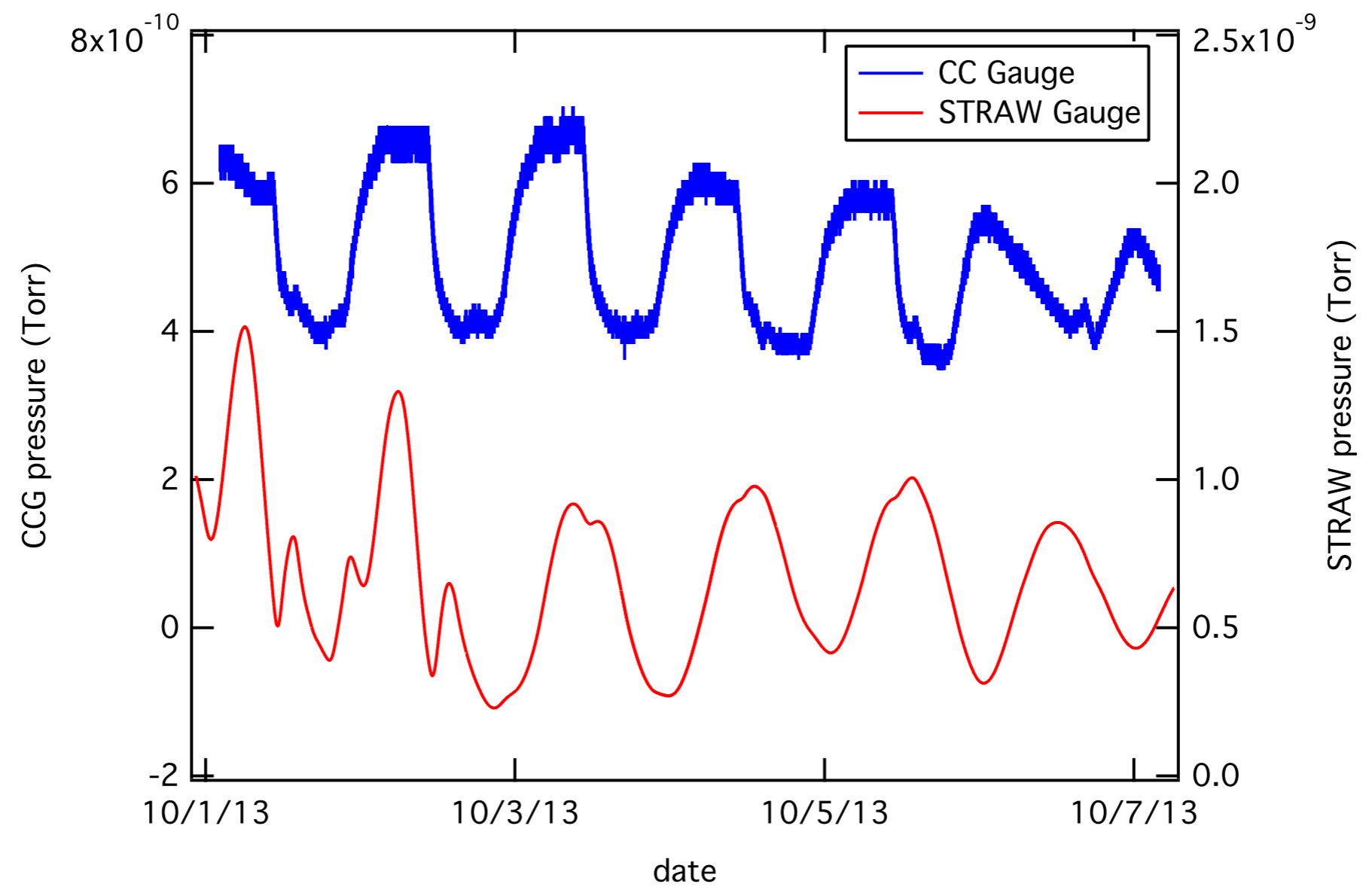
Conductance slope vs time



- Instrument in operation



STRAW UI on low end laptop running Windows XP



Comparison of pressure vs time for the STRAW vs. CCG





– Construction/connectorizing

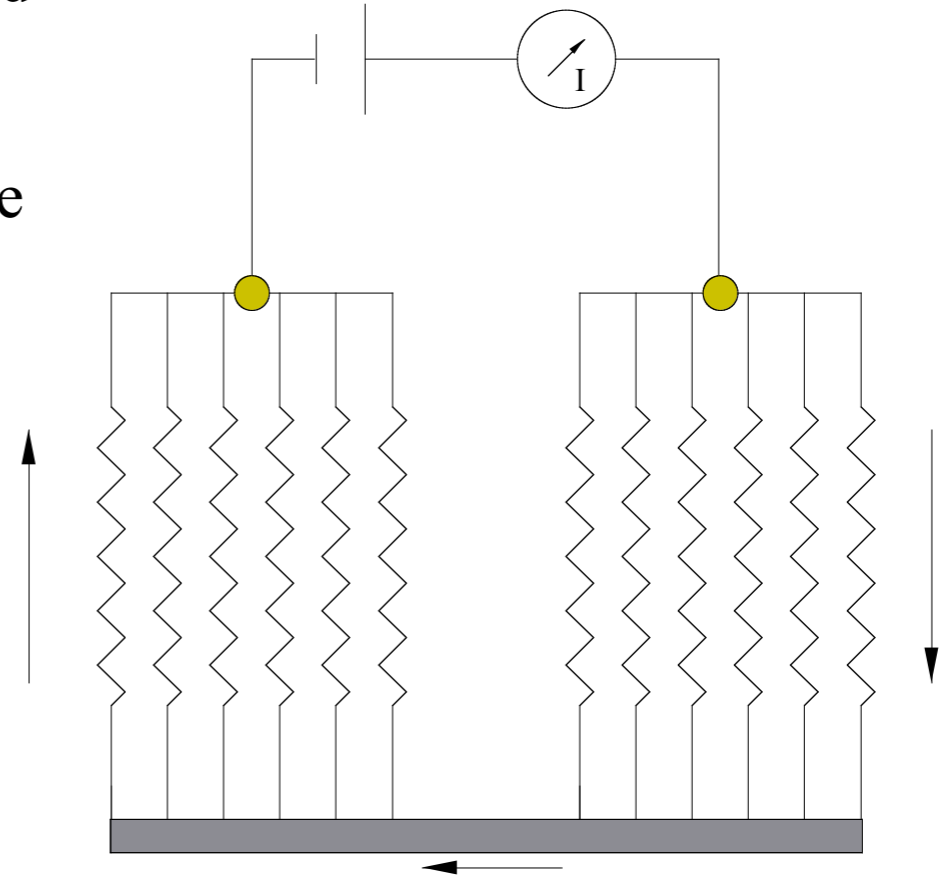
- \* Glass substrate clamp mounted on TO8-550 header (Kovar, Au, glass)
- \* Anodized films are ~transparent
- \* Pt contact pads Au wire bonded to header pins





– Operational electrical characteristics

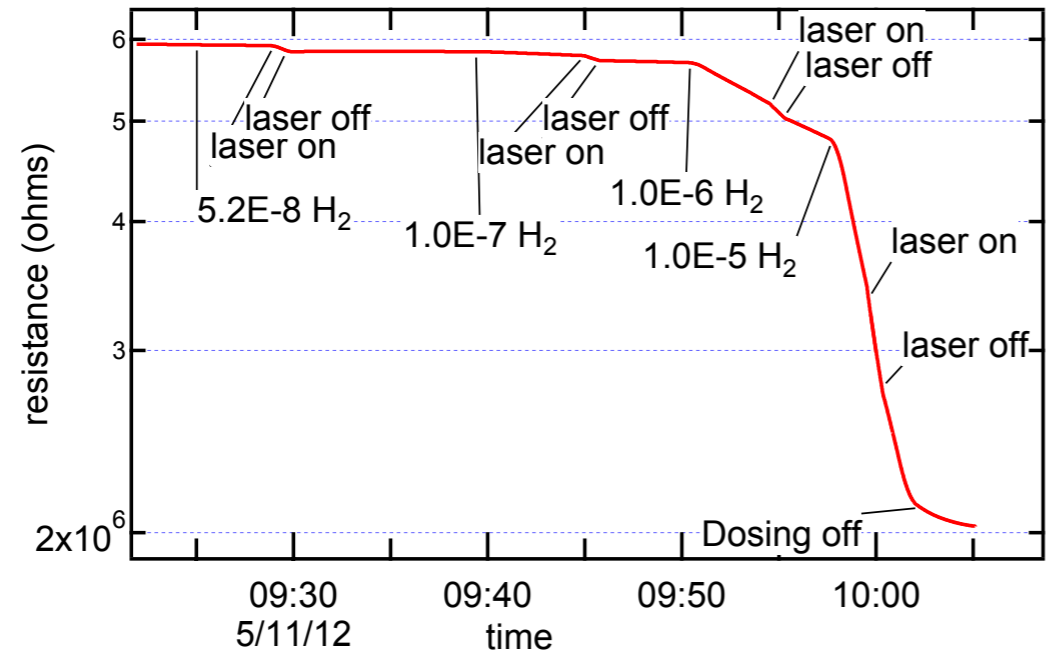
- \* Signal conversion very simple!  $V = IR$  (or  $V=I/G$ )
- \* Operational parameters: Bias = 0.40 V,  $I \leq 20 \mu A$
- \* Tolerant device, but best if handled as ESD sensitive
- \* Single point grounding used to eliminate ground loop noise
- \* Most other electrical noise eliminated by simple signal averaging (100x)
- \* Stability of high quality off-the-shelf measurement instruments sufficient



Simplified 1D diagram of nanotube array electrical circuit. Each parallel cluster is made up of the nanotubes under the individual Pt contact pads.

- Details, details, details

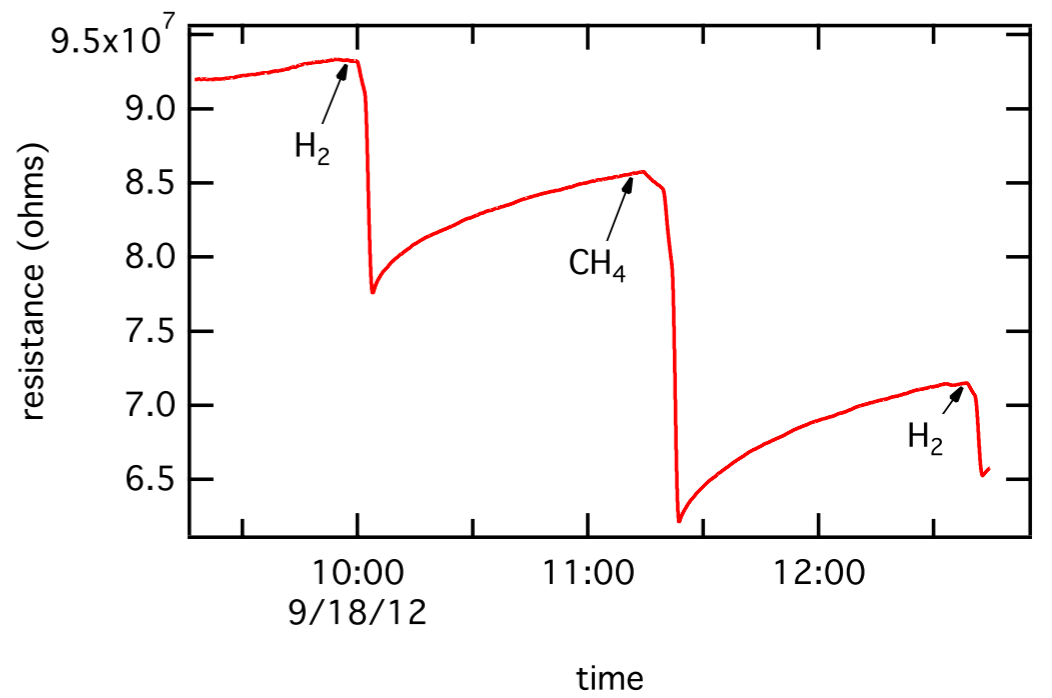
\* Sensitivity boost for lowest pressure operation



Enhanced sensitivity via illumination

\* Other gasses influence sensitivity

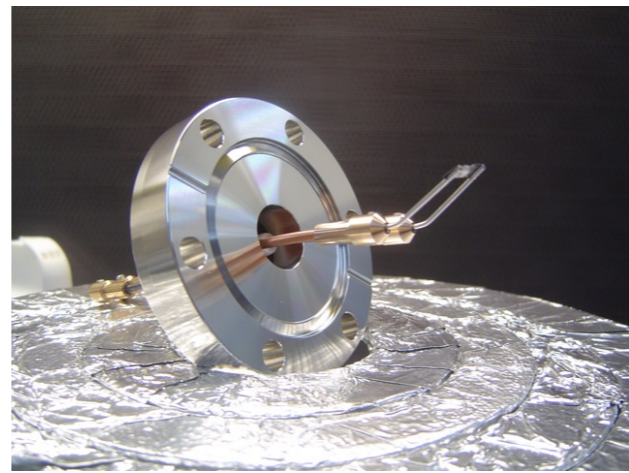
CH<sub>4</sub> yes, CO yes, CO<sub>2</sub> no



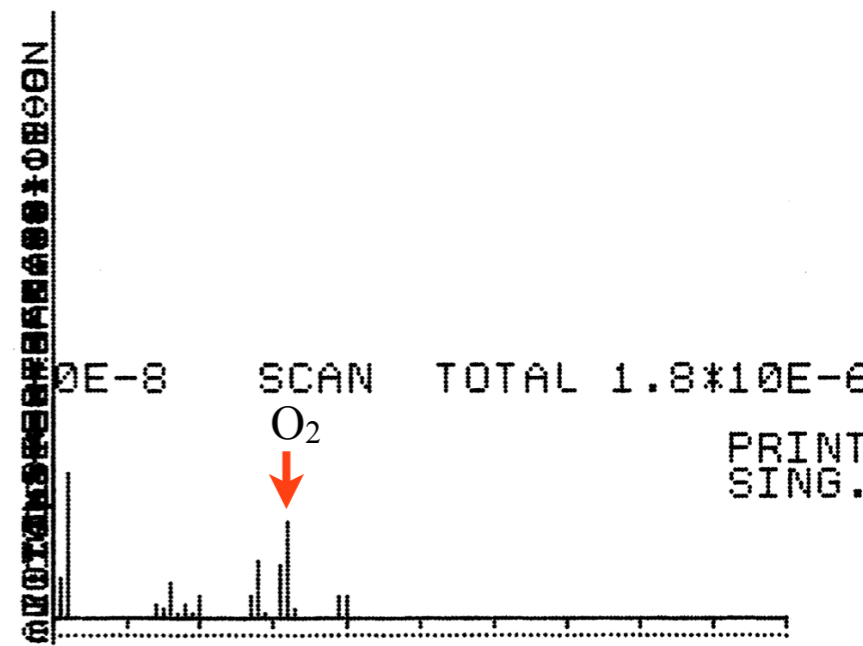
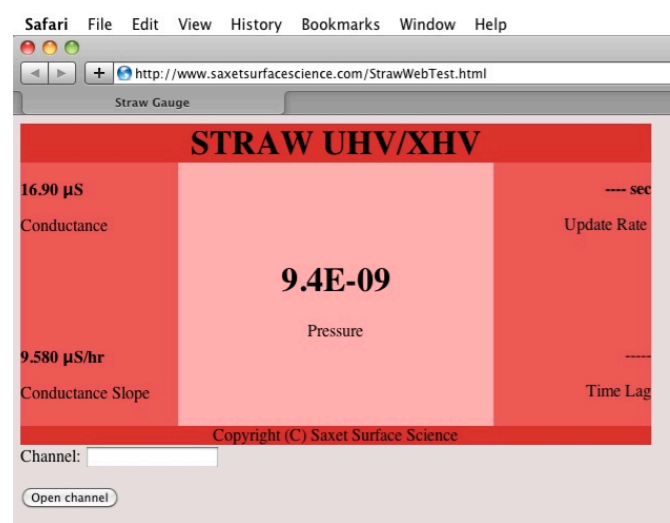
\* Titania is semiconducting, large TCR

• Add-ons/Spin outs

- Integral oxygen source for hydrogen absorption reversal. Silver oxide in stainless steel sleeve. One shot only!



- Web-based interrogation of host computer



RGA spectrum while operating oxygen source

- Remote readout of pressure with 'stale' data watchdog



- Market control board as low cost low voltage alternative for semiconducting nano-device I-V characterization  
Stability meets or exceeds that of commercial instruments (multi-task, so much higher \$\$\$)

# Saxet

Saxet is a sole proprietorship founded in 2002

– Who did the work?



Program management

Greg Mulhollan



Vacuum technology expert

Robert Kirby



System construction/measurement

John Bierman



Control system

Andrew Milder



– Where was the work done?



– 1,982 ft<sup>2</sup> in the Pecan Business Park in south Austin

– Texas is the 28th state and was a republic prior to statehood



– Austin is home to the Texas state capital, the University of Texas and many high-tech companies including Samsung (flash memory chips & mobile device processors)



# Summary

- STRAW UHV/XHV vacuum gauge system constructed
  - Does not perturb system
  - On-flange controller, host computer readout
- Titania nanotube sensor technology
  - High hydrogen sensitivity, with optical boost even better
  - Sensor technology tested, tested and tested some more!
- One unit is out currently for beta testing
- Future
  - Phase IIB or not to Phase IIB?
  - Commercialization
    - \* Direct sales
    - \* Two entities shown interest as product line



- Measuring pressure at UHV and XHV is not easy!

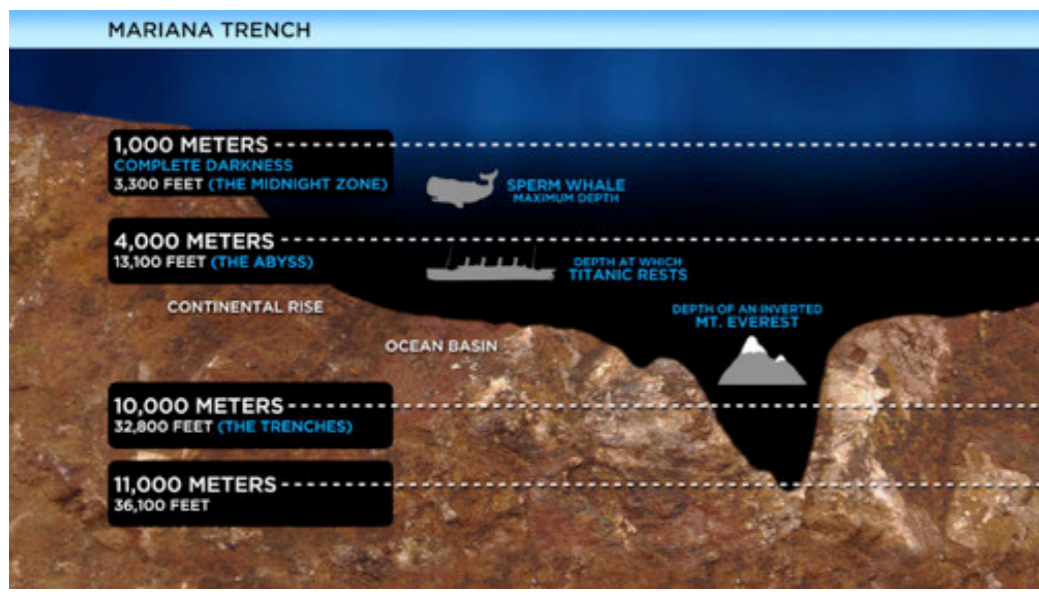
Atmosphere to  $10^{-12}$  Torr  
requires a drop of 15 orders of  
magnitude in pressure.

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Going beyond normal limits...

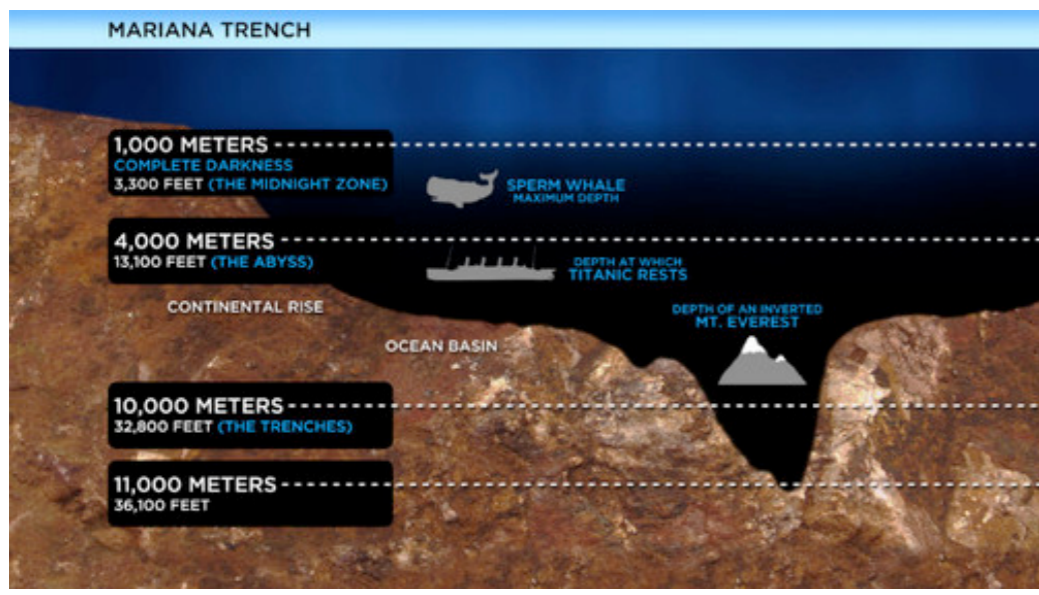
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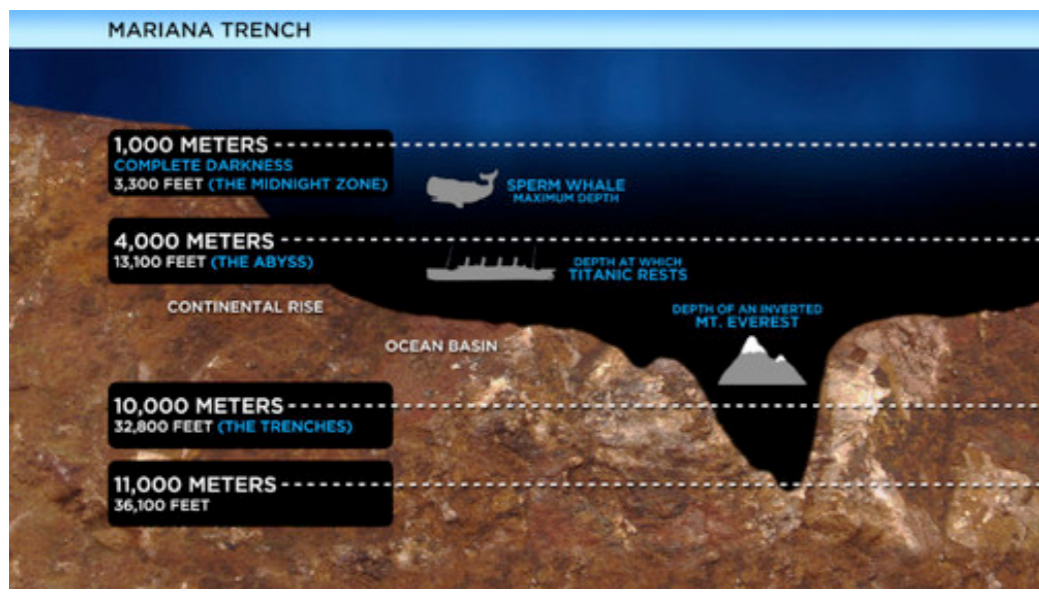
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Going beyond normal limits...

Requires specialized equipment...

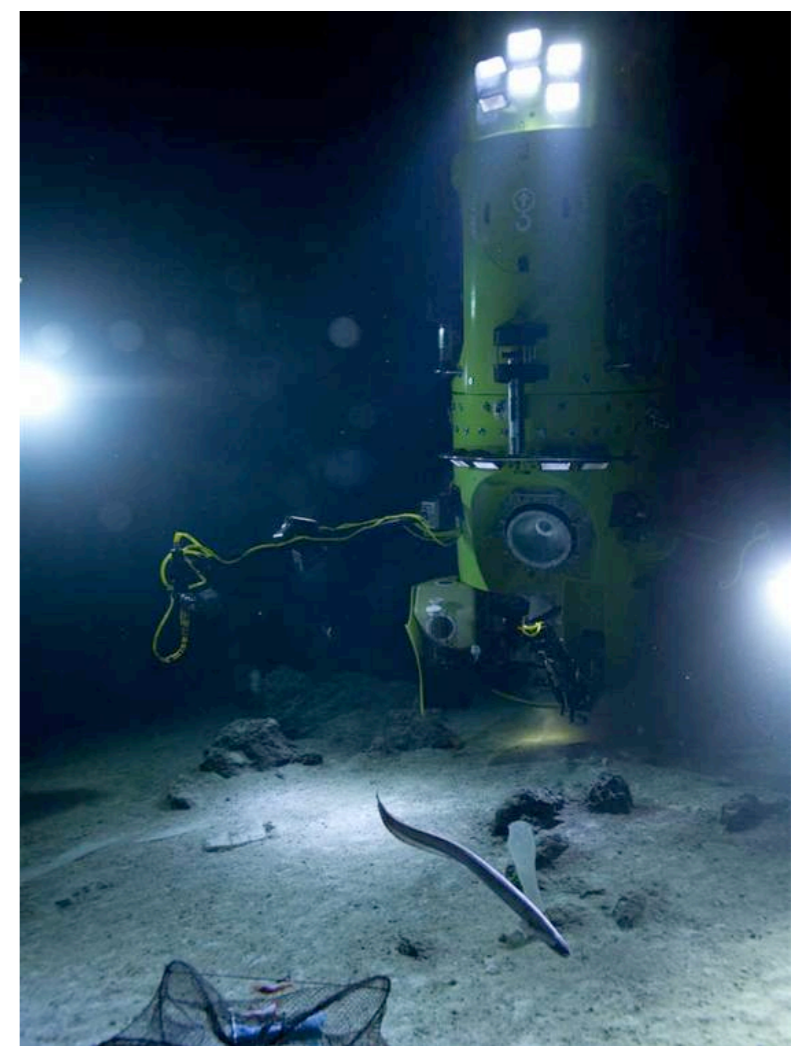


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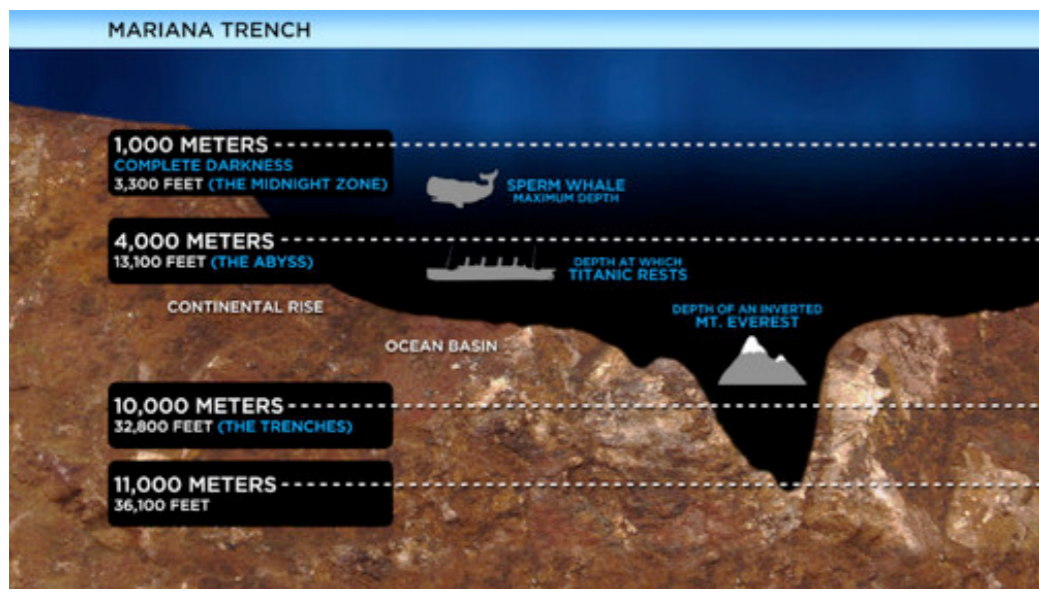
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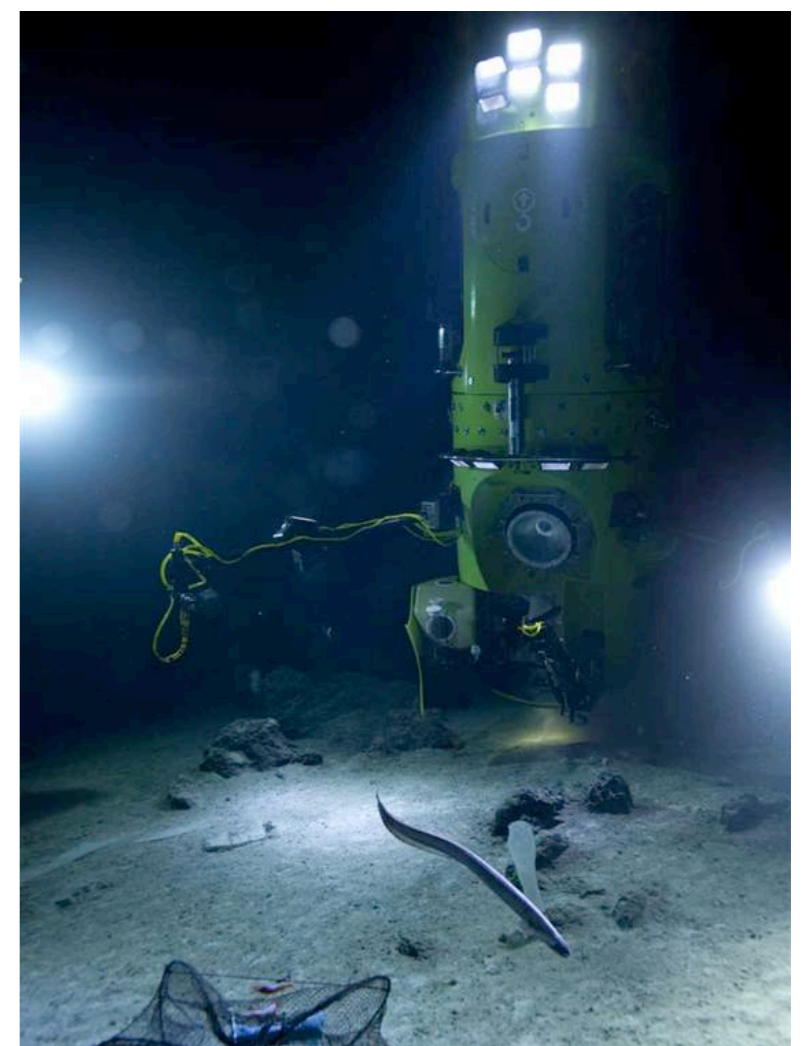


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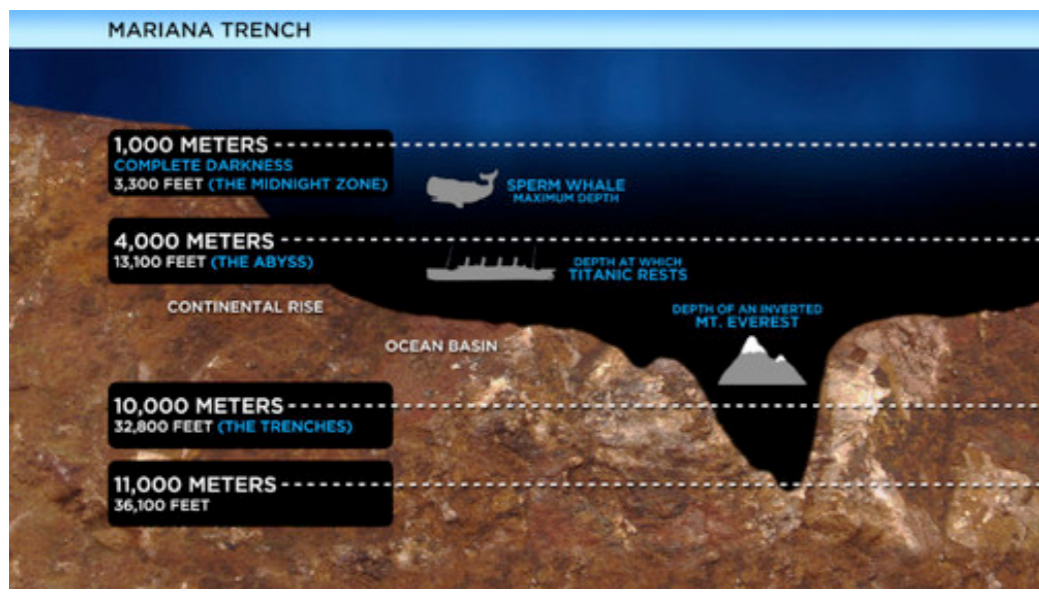
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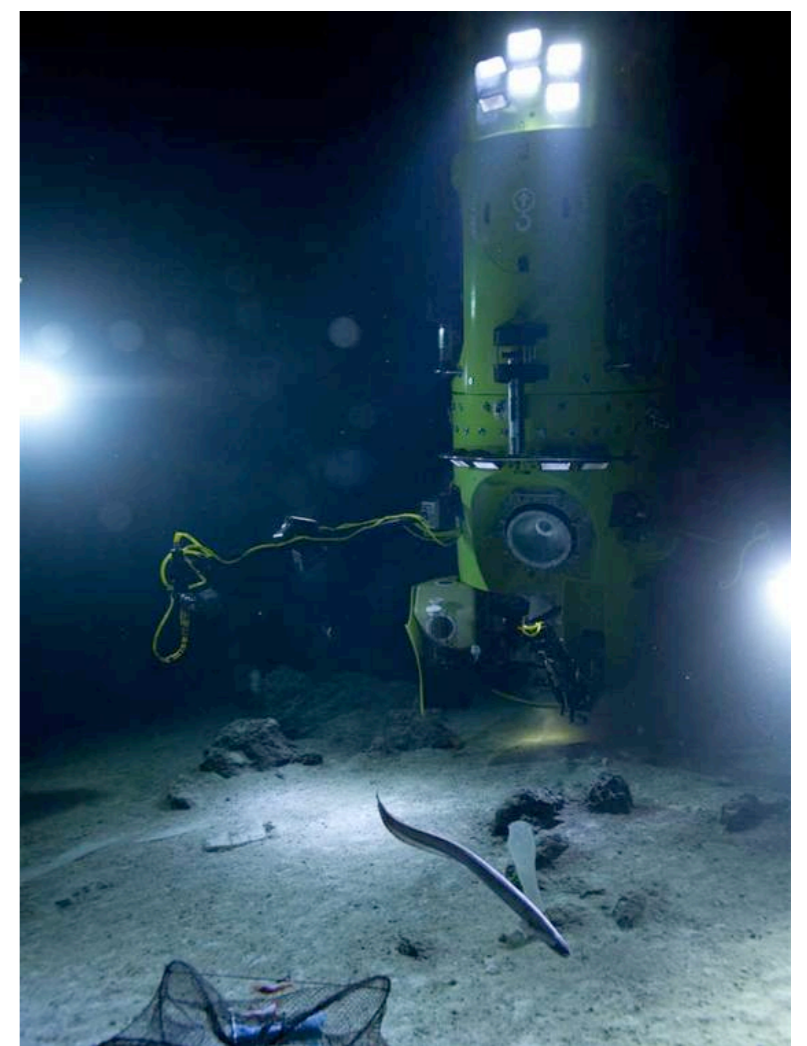
And a good deal of nerve!



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